

In the claims:

Please amend claims 80, 82, 85, 88, 91, 94, 97, 100 and 103 as follows:

80. (Amended) A multi-chamber system comprising:

a first chamber for irradiating laser light to a semiconductor film formed over a substrate;

a second chamber for depositing a gate insulating film on said semiconductor film; and

[A] a third chamber capable of taking said substrate out of said multi-chamber system after depositing said gate insulating film.

82. (Amended) A multi-chamber system according to claim 81 wherein [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

85. (Amended) A multi-chamber system according to claim 84 wherein [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

88. (Amended) A multi-chamber system according to claim 87 wherein [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

91. (Amended) A multi-chamber system according to claim 90 wherein [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

I 4
94. (Amended) A multi-chamber system according to claim 93 wherein [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

I 7
97. (Amended) A multi-chamber system according to claim 96 wherein [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

I 8
100. (Amended) A multi-chamber system according to claim 99 wherein [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

I 9
103. (Amended) A multi-chamber system according to claim 102 wherein [said apparatuses are capable of forming] a silicon oxide film is formed by one of said apparatuses.

✓ Please add new claims 104-123 as follows:

pat 59
I 10
✓ 104. (New) A multi-chamber system according to claim 80 wherein said laser light comprises an excimer laser light.

✓ 105. (New) A multi-chamber system according to claim 80 wherein said laser light has a linear shape.

✓ 106. (New) A multi-chamber system according to claim 83 wherein said laser light comprises an excimer laser light.

112, 2nd TP
105, 107, 109,
112, 115, 117,
Pg 17, lines 11, 122
"rectangular
shape"

✓ 107. (New) A multi-chamber system according to claim 83 wherein said laser light has a linear shape.

✓ 108. (New) A multi-chamber system according to claim 86 wherein said laser light comprises an excimer laser light.

✓ 109. (New) A multi-chamber system according to claim 86 wherein said laser light has a linear shape.

110. (New) A multi-chamber system according to claim 86 wherein said means for transporting said substrate comprises a robot hand.

✓ 111. (New) A multi-chamber system according to claim 89 wherein said laser light comprises an excimer laser light.

✓ 112. (New) A multi-chamber system according to claim 89 wherein said laser light has a linear shape.

113. (New) A multi-chamber system according to claim 89 wherein said means for transporting said substrate comprises a robot hand.

✓ 114. (New) A multi-chamber system according to claim 92 wherein said laser light comprises an excimer laser light.

✓ 115. (New) A multi-chamber system according to claim 92 wherein said

laser light has a linear shape.

✓ 116. (New) A multi-chamber system according to claim 95 wherein said laser light comprises an excimer laser light.

✓ 117. (New) A multi-chamber system according to claim 95 wherein said laser light has a linear shape.

✓ 118. (New) A multi-chamber system according to claim 98 wherein said laser light comprises an excimer laser light.

✓ 119. (New) A multi-chamber system according to claim 98 wherein said laser light has a linear shape.

120. (New) A multi-chamber system according to claim 98 wherein said means for transporting said substrate comprises a robot hand.

121. (New) A multi-chamber system according to claim 101 wherein said laser light comprises an excimer laser light.

122. (New) A multi-chamber system according to claim 101 wherein said laser light has a linear shape.

123. (New) A multi-chamber system according to claim 101 wherein said means for transporting said substrate comprises a robot hand.